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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)		<b>Complete if Known</b>			
		Application Number	10/812,492		
		Filing Date	March 30, 2004		
		First Named Inventor	Walter E. Donovan		
		Art Unit	2676		
		Examiner Name	Unknown		
Sheet	1	of	1	Attorney Docket Number	NVDA P000850

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
MR		McCormack, Joe, et al., "Feline: Fast Elliptical Lines for Anisotropic Texture Mapping," Mitsubishi Electric Information Technology Center America, 2000.	
MR		Greene, Ned, et al., "Creating Raster Omnimax Images from Multiple Perspective Views Using the Elliptical Weighted Average Filter," IEEE Computer Graphics and Applications, Vol. 6, Issue 6, pp. 21-27, June 1986.	
MR		Williams, Lance, "Pyramidal Parametrics," Computer Graphics, Vol. 17, No. 3, July 1983.	
MR		Heckbert, Paul S., "Fundamentals of Texture Mapping and Image Warping," Master's Thesis, Dept. of Electrical Engineering and Computer Science, University of California, Berkeley, CA, June 17, 1989.	
MR		"ATI's Optimized Texture Filtering Called Into Question," Tom's Hardware Guide, December 17, 2004. < <a href="http://www20.graphics.tomshardware.com/graphic/20040603/index.html">http://www20.graphics.tomshardware.com/graphic/20040603/index.html</a> >	
MR		Heckbert, Paul, "Texture Mapping Polygons In Perspective," Computer Graphics Lab, New York Institute of Technology, Technical Memo No. 13, April 28, 1983.	

Examiner Signature	/Manucher Rahmjoo/ (07/06/2006)	Date Considered	07/06/2006
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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